

CS98-076

SERIAL NO. : 09/262,000



To: COMMISSIONER OF PATENTS AND TRADEMARKS
Washington, D.C. 20231

From : George O. Saile (Reg. No. 19,572)
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Date: September 20, 2002

REF: APPLICANT : Kong, Sik On
SERIAL NO. : 09/262,000
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ATT'Y NO. : CS98-076
EXAMINER : Vockrodt, Jeff B.
TITLE : PHOTOLITHOGRAPHIC METHODS FOR MAKING
LIQUID-CRYSTAL-ON-SILICON DISPLAYS WITH ALIGNMENT
POSTS AND OPTICAL INTERFERENCE LAYERS
AMENDMENT AND RESPONSE TO OFFICE ACTION

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TECHNOLOGY CENTER 2800

Sir:

In response to an office action mailed on 06/20/01
please consider the following amendments and remarks with
respect to the above referenced application.

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being
deposited with the United States Postal service as First
Class mail in an envelop addressed to the Commissioner of
Patents and Trademarks, Washington, D.C. 20231, on
September 20, 2002.

Stephen B. Ackerman
(Reg. No 37,761)



Signature

9/20/02

Date